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02/10/2005 15:59 FAX 5098383424	WELLS ST JOHN PS	002/006
Practitioner's Docket No. M122-2391		PATENT
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE		
In re application of: Werner Jaengling		
Application No.: 10/078,513	Group No.: 2823	
Filed: 10/03/03	Examiner: B. Kebede	
Inv. Semiconductor Processing Methods of Forming a Contact Opening in a Conductive Line and Methods of Forming Substrate Active Area Sources/Drain Regions		
Commissioner for Patents Washington, D.C. 20231		
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Patent Application Serial No. 10/678,513
Filing Date October 3, 2003
Inventor Werner Juengling
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner B. Kebede
Attorney Docket No. MI22-2391
Title: Semiconductor Processing Methods of Forming a Contact Opening to a
Conductive Line and Methods of Forming Substrate Active Area
Source/Drain Regions

Assistant Commissioner for Patents
Washington, D.C. 20231

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5. Copy of page 1, PAIR Information page to 10/678,513

Dated: 22 Sept 2005

By: Rhonda G. Rambo

Rhonda G. Rambo

Telephone No. (509) 624-4276

NUMBER OF PAGES IN FACSIMILE: 6

NOTE: According to our records; our PTO Deposit Account (number 23-0925) has not been charged \$180.00 for the Supplemental Information Disclosure Statement filed on 2/10/05. Please verify your records; according to the PAIR information page, the USPTO has noted the Supplemental Information Disclosure Statement was filed on 2/10/05.

Regards,

Rhonda
Rhonda

Practitioner's Docket No. MI22-2391

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Werner Juengling

Application No.: 10/678,513
Filed: 10/03/03Group No.: 2823
Examiner: B. KebedeFor: Semiconductor Processing Methods of Forming a Contact Opening to a Conductive Line and
Methods of Forming Substrate Active Area Source/Drain RegionsCommissioner for Patents
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/678,513
Filing Date October 3, 2003
Inventor Werner Juengling
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner B. Kebede
Attorney's Docket No. MI22-2391
Customer No. 021567

Title: Semiconductor Processing Methods of Forming a Contact Opening to a
Conductive Line and Methods of Forming Substrate Active Area
Source/Drain Regions

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References --See Attached Form PTO-1449

The attached Form PTO-1449 is submitted in compliance with 37 C.F.R. §§
1.56. Pursuant to Federal Register Vol. 69, No. 182, pg. 56542 (September 21,
2004), no copies of any cited U.S. patents or U.S. published applications are
included herewith. Copies of all other cited art references are attached. No
admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

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Respectfully submitted,

Dated: 2-10-05By: 

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U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
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	AB						
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10/678,513

Semiconductor processing methods of forming a contact on
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regions

Transaction History	Date	Contents Description
	08-30-2005	Date Forwarded to Examiner
	08-22-2005	Response after Non-Final Action
	08-22-2005	Request for Extension of Time - Granted
	08-16-2005	Miscellaneous Incoming Letter
	04-20-2005	Mail Non-Final Rejection
	04-18-2005	Non-Final Rejection
	02-10-2005	Information Disclosure Statement (IDS) Filed
	02-08-2005	Paralegal TD Accepted
	01-18-2005	Terminal Disclaimer Filed
	01-18-2005	Information Disclosure Statement (IDS) Filed
	02-08-2005	Date Forwarded to Examiner
	01-18-2005	Response after Non-Final Action
	01-18-2005	Workflow Incoming amendment IFW
	10-19-2004	Mail Non-Final Rejection
	10-18-2004	Non-Final Rejection
	05-20-2004	IFW TSS Processing by Tech Center Complete
	05-20-2004	Case Docketed to Examiner in GAU
	05-11-2004	Reference capture on IDS
	10-03-2003	Reference capture on IDS
	05-11-2004	Information Disclosure Statement (IDS) Filed
	10-03-2003	Information Disclosure Statement (IDS) Filed
	10-03-2003	Preliminary Amendment
	12-30-2003	Application Is Now Complete
	12-30-2003	Application Return from OIPE
	12-30-2003	Application Return TO OIPE
	12-30-2003	Application Is Now Complete
	12-29-2003	Application Dispatched from OIPE